



ELECTRONIC COPY

LG799659416
Report verification at igi.org



May 12, 2026

IGI Report Number **LG799659416**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **6.67 X 6.65 X 4.78 MM**

GRADING RESULTS

Carat Weight **1.84 CARAT**

Color Grade **D**

Clarity Grade **VS 1**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

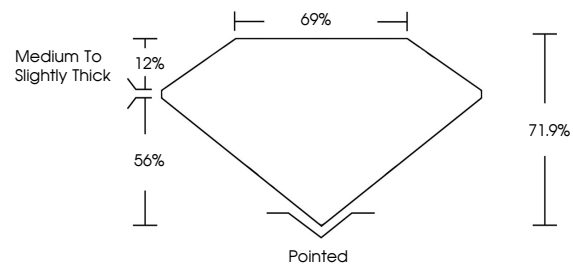
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG799659416**

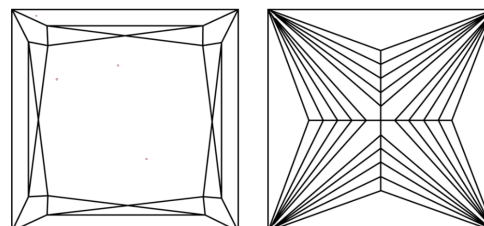
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

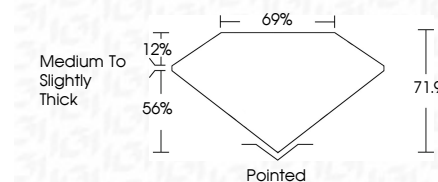
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



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IGI Report No. LG799659416
PRINCESS CUT

1.84 CARAT
D

6.67 X 6.65 X 4.78 MM
6.67
6.65
4.78

Carat Weight
Color Grade
Clarity Grade
Table
Depth
Girdle
Medium to Slightly Thick

Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG799659416

Culet
Polish
Symmetry
Fluorescence
Inscription(s)

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